



PATENT

Atty. Dkt. No. AMAT/4471.Y1/CMP/ECP/RKK

1753

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Zheng, et al.

Serial No.: 09/614,407

Confirmation No.: 1903

Filed: July 12, 2000

For: Method of Application of
Electrical Biasing To
Enhance Metal Deposition

§
§
§
§
§
§
§
§
§
§
§
§

Group Art Unit: 1753

Examiner: Brian L. Mutschler

MAIL STOP NON-FEE AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING
37 CFR 1.8

I hereby certify that this correspondence is being deposited on December 22, 2003, with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Dec. 22, 2003
DateAli Khamis
Signature

Dear Sir:

RESPONSE TO OFFICE ACTION DATED OCTOBER 20, 2003

In response to the Office Action dated October 20, 2003, having a shortened statutory period for response set to expire on January 20, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicants believe that no fee is due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/ AMAT/4471.Y1/AOP, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks/Arguments begin on page 6 of this paper.